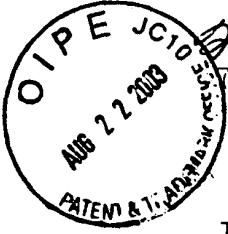


30

2877

I hereby certify that this correspondence is being deposited with the United States postal service as in an envelope addressed to: Commissioner of Patents and Trademarks, Alexandria, VA 22313-1450, on 8/20/03.  
The applicant and/or attorney requests the date of deposit as the filing date.  
Depositor: KAREN CINO-MARS



Karen Cino-Mars 8/20/03  
(Signature & date)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of \_\_\_\_\_: 8/20/03  
Mitsuru Uda, et al.: Group Art Unit:  
Serial No. 10/045,377: Examiner:  
Filed: 11/09/01 International Business  
Machines Corporation  
2070 Route 52  
Hopewell Junction, NY 12533

TITLE: METHOD AND APPARATUS FOR INSPECTING RESIST PATTERN

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents  
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure set forth in 37 C.F.R. 1.56, and further pursuant to the provisions of 37 C.F.R. 1.97 and 1.98, applicants hereby respectfully submit copies of the prior patents and publications as listed on Form PTO-1449, attached hereto.

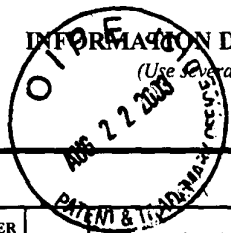
In citing these documents, no representation is made nor intended as to the pertinency or non-pertinency of the art, that better art than that listed is not available, or that other art is not applicable.

Respectfully submitted,  
Mitsuru Uda, et al.

By James J. Cioffi  
James J. Cioffi, Attorney  
Registration No. 51,564  
Telephone No. 845-894-3363

# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional)

JP920000352US1

Application Number

10/045,377

Applicant(s)

MITSURU UDA, ET AL.

Filing Date

11/09/01

Group Art Unit

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		11-142345	28.05.1999	JAPAN				

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER	DATE CONSIDERED
----------	-----------------

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.